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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Gilton et al.

Application No. 09/321,518

Filed: May 27, 1999

For: SEMICONDUCTOR FABRICATION
APPARATUS

Examiner: Wai-Sing Louie

Date: August 12, 2002

BOX RCE
COMMISSIONER FOR PATENTS
WASHINGTON, DC 20231

Art Unit: 2814

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service on August 12, 2002 as first class mail in an envelope addressed to: BOX RCE, COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231.

Attorney for Applicant

**REQUEST FOR CONTINUED EXAMINATION
TRANSMITTAL LETTER**

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the application referenced above.

Submission required under 37 C.F.R. § 1.114:

- ☐ Previously submitted
- ☐ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on _____
(Any unentered amendment(s) referred to above will be entered).
- ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
- ☐ Other _____
- ☒ Enclosed
- ☒ Preliminary Amendment/Reply
- ☐ Affidavit(s)/Declaration(s)
- ☐ Information Disclosure Statement (IDS)
- ☐ Other

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Attorney Reference Number 6047-51973

Application Number 09/321,518

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Terry L. Gilton and Li Li

Art Unit: 2814

Application No. 09/321,518

Filed: May 27, 1999

For: SEMICONDUCTOR FABRICATION APPARATUS

Examiner: Wai-Sing Louie

Date: August 12, 2002

BOX RCE
 COMMISSIONER FOR PATENTS
 WASHINGTON, D.C. 20231

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on August 12, 2002 as First Class Mail in an envelope addressed to: BOX RCE, COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Attorney for Applicant

PRELIMINARY AMENDMENT

In response to the Office action dated May 10, 2002, please amend claims 39, 42, 44, 46, 50, 51, 55 and 56 of the present application as follows:

39. (Twice Amended) An apparatus for cleaning semi-conductor wafers, the wafers having first and second wafer side surfaces, the apparatus comprising:
- a chamber sized to receive at least one wafer to be cleaned;
- a solvent applicator coupled to the chamber and adapted to vaporize and apply a solvent to at least one of the first and second side surfaces of the wafer positioned within the chamber so as to form a film of liquid solvent on said at least one of the first and second wafer side surfaces, the liquid solvent being inert to said at least one of the first and second wafer side surfaces;

Miscellaneous

- ☐ Petition for suspension of action on the application referenced above is under 37 C.F.R. § 1.103(c) for a period of _____ months. (Fee under 37 C.F.R. § 1.17(i) required)
- ☐ Other

FILING FEE

For	No. after amendment	No. paid for previously	Present Extra	Rate	Fee
Fee under 37 CFR 1.17(e)					\$740.00
Total Claims	18	46*	= 0	\$18.00	\$ 0.00
Indep. Claims	8	16**	= 0	\$84.00	\$ 0.00
TOTAL FILING FEE					\$740.00

* greater of twenty or number for which fee has been paid.

** greater of three or number for which fee has been paid.

- ☒ A check in the amount of \$740.00 is attached.
- ☒ Please charge any additional fees that may be required in connection with filing this amendment and any extension of time, or credit any overpayment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- ☒ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

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